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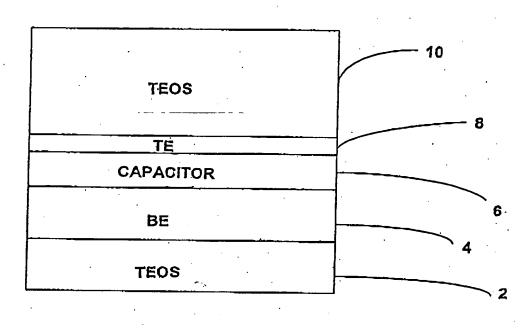


Fig. 1a (prior art)

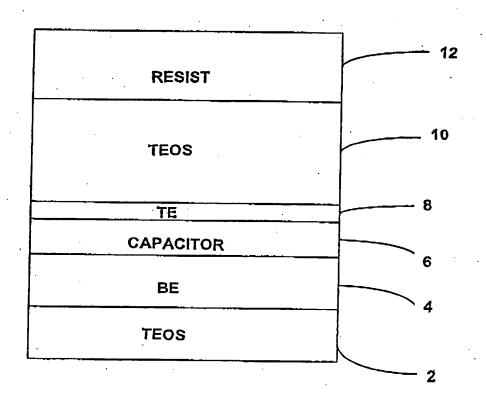


Fig. 1b (prior art)

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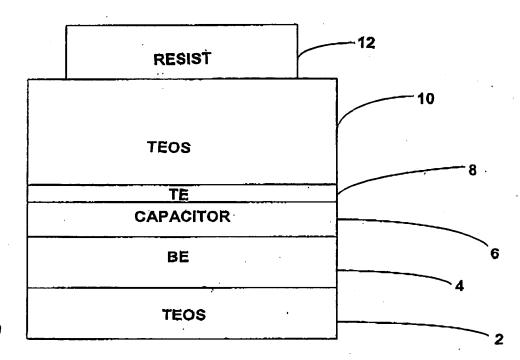


Fig. 1c (prior art)

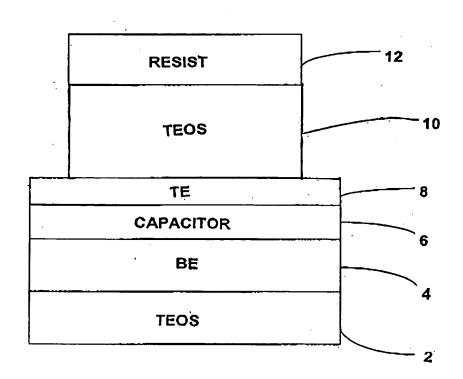


Fig. 1d (prior art)

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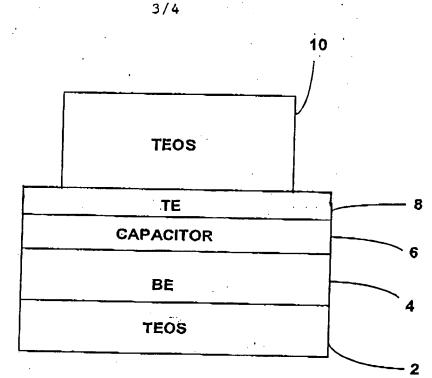


Fig. 1e (prior art)

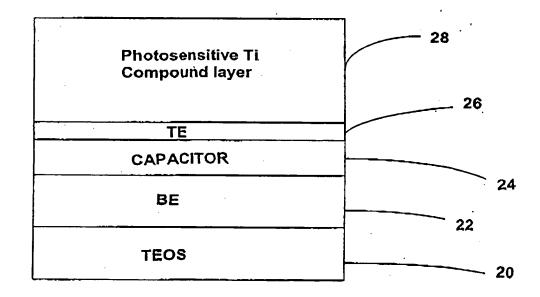


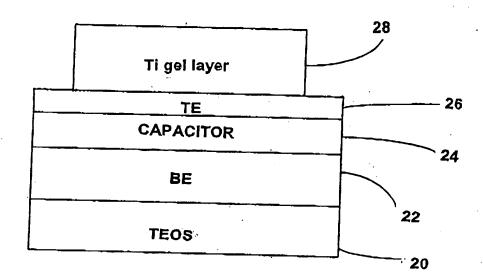
Fig. 2a

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Fig. 2b



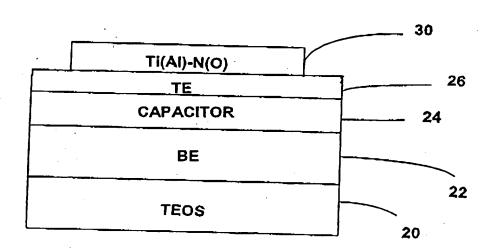


Fig. 2c